



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kusumoto, et al. Art Unit : 2823
Serial No. : 10/025,322 Examiner : Julio J. Maldonado
Filed : December 18, 2001
Title : LASER ANNEALING METHOD AND LASER ANNEALING DEVICE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO ELECTION OF SPECIES REQUIREMENT

Responsive to the action mailed August 22, 2005, applicant elects the invention of Species 1, directed to a method of manufacturing a semiconductor device including forming an oxide film on a surface of a semiconductor film when applying a laser beam. Claims 1-3, 19-21, 23-25, 27, 29, 30 and 36-39 are believed to be readable on the elected species. This election is made without traverse.

Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 9/22/05


John F. Hayden
Reg. No. 37,640

Customer No. 26171
Fish & Richardson P.C.
1425 K Street, N.W., 11th Floor
Washington, DC 20005-3500
Telephone: (202) 783-5070
Facsimile: (202) 783-2331